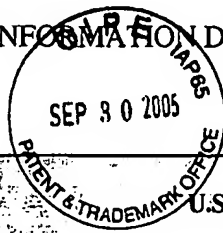


FORM PTO-1449  
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
133456-1SERIAL NO.  
10747,838

**SUPPLEMENTAL**  
**INFORMATION DISCLOSURE STATEMENT BY APPLICANT**  
**LIST OF ITEMS**

Applicant  
John Patrick Lemmon et al.Filing Date  
12/29/03Group  
1754

**U.S. PATENT DOCUMENTS & U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>JW</i>	A1	4,397,834	8/9/83	Mendelsohn et al.		
	A2	4,613,362	9/23/86	Welter et al.		
	A3	4,716,726	1/5/88	Nowaczyk		
	A4					
	A5					
	A6					
	A7					
	A8					
	A9					
	A10					
	A11					

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
<i>JW</i>	B1	DE 35 35 378	4/16/87	German		X
	B2	EP 0 355 207	2/28/90	European		X
	B3	WO 01/68515	9/20/01	PCT		X
	B4	WO 03/050447	6/19/03	PCT		X
	B5	WO 03/053848	7/3/03	PCT		X
	B6					
	B7					
	B8					
	B9					
	B10					

**OTHER INFORMATION** (Including Author, Title, Date, Pertinent Pages, etc.)

<i>JW</i>	C1	European Search Report dated September 9, 2005.
	C2	
	C3	

EXAMINER

DATE CONSIDERED

6/14/06

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<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)				ATTY DOCKET NO. 133456-1		SERIAL NO. 10/747,838	
				Applicant(s): John Patrick Lemmon et al			
				FILING 12/29/2003		GROUP	
<b>U.S. PATENT DOCUMENTS</b>							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
TN	4,820,226	04/11/1989	Hsu				
	5,389,333	02/14/1995	Li et al				
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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO	
	EP 1 116 797 A1	07/18/2001	European Patent Office				
	WO 95/25355	09/21/1995	WIPO				
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		Ji-Cheng Zhao, "A Combinatorial Approach for Structural Materials", <i>Advanced Engineering Materials</i> 2001, 3, No. 3, pp. 143-147					
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EXAMINER <i>[Signature]</i>				DATE CONSIDERED 6/14/06			
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<p><b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)</p> <p><b>APR 19 2004</b></p>		Docket Number (Optional) <b>133456-1</b>	Application Number <b>10/747,838</b>
		Applicant(s) <b>John Patrick Lemmon et al</b>	
Filing Date <b>12/29/2003</b>		Group Art Unit	
*EXAMINER INITIAL	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
<p><i>[Handwritten: JW]</i></p> <p><i>[Vertical line through the column]</i></p>	Hydride Basics, "Solid-H(TM) Metal Hydrides", U.S. Patent No. 4,600,525, <a href="http://www.hydrogencomponents.com/hydride.html">http://www.hydrogencomponents.com/hydride.html</a> , 9/6/2003, pp. 1-3.		
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	Thomas F. Jaramillo et al, "Articles, High-Throughput Screening System for Catalytic Hydrogen-Producing Materials", <i>J. Comb. Chem.</i> 2002, 4, 17-22.		
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	Wim Soppe et al, Institute of Microtechnology (IMT), Microwave Plasma Assisted VHF-PECVD of Micro-Crystalline Silicon		
	A.F. Djakov, V.D. Rusanov, RAO "EES Russia", Russia, Hydrogen In Energy In Long-Term Prospect, World Energy Council, <a href="http://www.worldenergy.org/wec-geis/publications/default/tech_papers/17th_congress/3_3_09.asp">http://www.worldenergy.org/wec-geis/publications/default/tech_papers/17th_congress/3_3_09.asp</a> , 9/12/2003, pp. 1-6.		
Hydrogen Review Article, Hydrogen Review, <a href="http://naftp.nrcce.wvu.edu/techinfo/altfuels/H2/Hydrogen.html">http://naftp.nrcce.wvu.edu/techinfo/altfuels/H2/Hydrogen.html</a> , 9/11/2003, pp. 1-10.			
Thomas Klassen et al, Nanocrystalline Mg-based Hydrides: Hydrogen Storage for the Zero-Emission Vehicle			
EXAMINER	<p><i>[Handwritten Signature]</i></p>		DATE CONSIDERED <b>6/14/06</b>
<p>*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>			

<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)		Docket Number (Optional) <b>133456-1</b>	Application Number <b>10/747,838</b>
		Applicant(s) <b>John Patrick Lemmon et al</b>	
		Filing Date <b>12/29/2003</b>	Group Art Unit
*EXAMINER INITIALS OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
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EXAMINER	<i>Paul W. Utter</i>	DATE CONSIDERED	<i>6/14/08</i>
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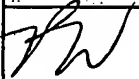
Applicant  
John Patrick Lemmon et al.Filing Date  
12/29/03Group  
1754**U.S. PATENT DOCUMENTS & U.S. PATENT APPLICATION PUBLICATIONS**

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PW ↓	A1	4,613,362	9/23/86	Welter et al.		
	A2	4,716,736	1/5/88	Schwarz		
	A3					
	A4					
	A5					
	A6					
	A7					

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PW ↓	B1	WO 01/68515	9/20/01	PCT			X	
	B2	WO 03/050447	6/19/03	PCT			X	
	B3	WO 03/053848	7/3/03	PCT			X	
	B4	DE 3535378	4/16/87	Germany				X
	B5							
	B6							

**OTHER INFORMATION** (Including Author, Title, Date, Pertinent Pages, etc.)

	C1	European Search Report dated June 8, 2005.
	C2	
	C3	
	C4	
	C5	

EXAMINER



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